

U.S. Department of Commerce, Patent and Trademark Office

Docket No.:

4260/P1/Y02/CMP/CMP/RKK

Serial No.:

09/843,582

## LIST OF RELEVANT ART CITED BY APPLICANT

(Use several sheets if necessary)

Applicant(s):

Yuchun Wang, Rajeev Bajaj and Fred C. Redeker

Filing Date:

04/26/01

Group:

3723

## Patent Documents

*Examiner Initial		Document Number	Issue Date	Name	Class	Subclass	Filing Date If Appropriate
DVN	AA	4,554,378✓	11/19/85	Nafziger et al.			
DVN	AB	5,019,311✓	05/28/91	Koslow			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

RECEIVED

AUG 27 2002

TECHNOLOGY CENTER R3700

## Foreign Patent Documents

Translation

		Document Number	Date	Country	Class	Subclass	Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	AR	
	AS	
	AT	

Examiner

Date Considered

10-7-2002

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.